

SPECIFICATION AMENDMENTS

Pages 3 and 4, bridging paragraph:

Further, proposed methods include a method to use a radiation image converting panel having a stimuable phosphor layer, in which, as described in Japanese Patent Application Open to Public Inspection No. 61-142500, cracks between columnar blocks, which are prepared by accumulating a stimuable phosphor on a support having a fine pattern, are subjected to a shock treatment so that the aforesaid cracks are allowed to grow and further, a method to use a radiation image converting panel in which, as described in Japanese Patent Application Open to Public Inspection No. ~~62-39737~~ 62-39797, a stimuable phosphor layer formed on a support is subjected to formation of cracks on the surface side to be pseudo-columnar, and further, a method in which, as described in Japanese Patent Application Open to Public Inspection No. 62-110200, a stimuable phosphor layer having voids is formed on a support, employing vacuum evaporation, and subsequently voids are allowed to grow by a thermal treatment so that cracks are provided.